

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Shunpei YAMAZAKI et al.

Serial No. 09/932,935

Filed: August 21, 2001

For: LASER APPARATUS, LASER

ANNEALING METHOD, AND

MANUFACTURING METHOD OF A

SEMICONDUCTOR DEVICE



Art Unit: 2812

Examiner: V. Simkovic

CERTIFICATE OF MAILING

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AMENDMENT

Commissioner for Patents
Washington, DC 20231

Sir:

In response to the Official Action dated April 15, 2003, please consider the
following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 10 of this paper.

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